

RECEIVED
CENTRAL FAX CENTER

JUN 17 2008

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/623,866 Confirmation No. : 6399
First Named Inventor : Yoshihiro KATO
Filed : July 22, 2003
TC/A.U. : 1763
Examiner : J. Lund

Docket No. : 101246.52582US
Customer No. : 23911

Title : Plasma Process System and Plasma Process Method

AMENDMENT AND RESPONSE UNDER 37 C.F.R. § 1.116

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In complete response to the final Office Action dated March 17, 2008, Applicant submits herewith the following Response.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this Response.

Remarks begin on page 10 of this Response.